



INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)

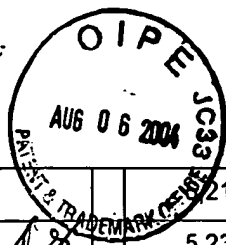
Atty. Docket No.: 99066CON (3600-198-02)	Application No.: 10/795,968
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Applicant:	HABECKER <i>et al.</i>
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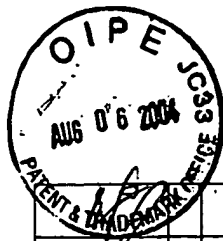
Filing Date: March 8, 2004	Group Art Unit: To Be Assigned
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Examiner Initial*	Document Number	Date	Name	Class	Sub Class	Filing Date If Appropriate
<i>g</i>	3,630,718	12/28/71	Neuenschwander	75	0.5	
	3,635,693	01/18/72	Friedrich et al.	75	0.5BB	
	3,647,420	03/07/72	Restelli	75	84	
	4,009,007	2/22/77	Fry	29	182.5	
	4,017,302	04/12/77	Bates et al.	75.5 BB	75/228	
	4,084,965	04/18/78	Fry	75	230	
	4,141,720	02/27/79	Vartanian	75	0.5BB	
	4,149,876	1/17/79	Rerat	75	0.5	
	4,231,790	11/04/80	Hahn et al.	75	0.5BB	
	4,347,084	08/31/82	Hahn et al.	75	245	
	4,356,028	10/26/82	Bates	75	0.5	
	4,441,927	4/10/84	Getz et al.	75	229	
	4,483,819	11/20/84	Albrecht et al.	419	2	
	4,512,805	04/23/85	Albrecht et al.	75	244	
	4,537,641	08/27/85	Albrecht et al.	148	11.5	
	4,544,403	10/1/85	Schiele et al.	75	0.5	
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	4,555,268	11/26/85	Getz	75	229	
	4,569,693	02/11/86	Albrecht et al.	75	252	
	4,684,399	08/04/87	Bergman et al.	75	0.5BB	
	4,722,756	02/02/88	Hard	148	126	
	4,740,238	04/26/88	Schiele	75	0.5BB	
	4,940,490	07/10/90	Fife et al.	75	229	
<i>ajf</i>	4,954,169	09/04/90	Behrens	75	228	



		211,741	05/18/93	Fife	7	255	
		5,234,491	08/10/93	Chang	75	622	
		5,242,481	09/07/93	Kumar	75	364	
		5,245,514	09/14/93	Fife et al.	361	529	
		5,261,942	11/16/93	Fife et al.	75	342	
		5,284,531	02/08/94	Fife	148	513	
		5,412,533	05/02/95	Murayama et al.	361	528	
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		6,165,623	12/2000	Fife	428	472	
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		6,479,012	11/12/02	Rao	419	36	
		6,576,038 B1	06/10/03	Rao	75	255	
		6,402,066 B1	06/11/02	Habecker et al.	241	21	
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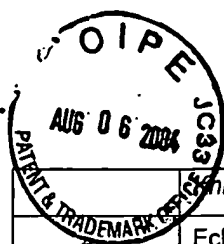
	6,702,869 B2	03/09/04	Habecker et al.	75	229	
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	CN 87 1 07675 A	05/18/88	China			No
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	JP 80027601 B	07/22/80	Japan			Yes (Abstract)
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	0 953 847 A1	03.11.99	Europe	G01R	31/26	Yes
	WO 00/08662 A1	2/17/00	WIPO	H01G	9/042	Yes
	WO 00/36617 A1	06/22/00	WIPO	H01G	9/04	Yes
	0 984 469 A2	03/08/00	Europe	H01G	9/042	Yes
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Examiner <i>[Signature]</i>		Date Considered <i>3/28/05</i>	
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			
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